



**RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2826**

PATENT
Attorney Docket No. 213578
Client Reference No. 20836

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Tadatomo et al.

Application No. 09/936,683

Art Unit: 2826

Examiner: F. Erdem

Filed: November 30, 2001

For: SEMICONDUCTOR BASE AND ITS
MANUFACTURING METHOD, AND
SEMICONDUCTOR CRYSTAL
MANUFACTURING METHOD

RESPONSE TO OFFICE ACTION


Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated May 21, 2003, please enter the following amendments and consider the following remarks.

09/25/2003 HBIZUNES 00000072 121216 09936683

01 FC:1202 342.00 DA
02 FC:1203 280.00 DA

CERTIFICATE OF MAILING UNDER 37 CFR 1.10			
I hereby certify that this Response to Office Action and all accompanying documents are being deposited with the United States Postal Service on September 22, 2003, in an envelope as "EXPRESS MAIL POST OFFICE TO ADDRESSEE" service under 37 CFR 1.10, Mailing Label Number EV 329750794 US, addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.			
Name (Print/Type)	John Kilyk, Jr.		
Signature		Date	September 22, 2003